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2813

PATENT
790001-2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Hiroyuki YANO et al.
Serial No. : 09/870,085
Filed : May 30, 2001
For : **MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE**
Examiner : Thanhha Pham
Group Art Unit : 2813

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AUG 21 2002
TECHNOLOGY CENTER 2800

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, DC 20231, on July 30, 2002.

Grace L. Pan, Reg. No. 39,440

Name of Applicants, Assignee or Registered Representative

Signature

July 30, 2002

Date of Signature

AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

This is in response to the Office Action mailed on April 30, 2002, which sets a three-month response period. Please amend this application as follows: